



Docket No.: 060188-0702

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Akio MISAKA	:	Confirmation Number: 8679
Application No.: 10/717,598	:	Group Art Unit: 1756
Filed: November 21, 2003	:	Examiner: Rosasco, Stephen D.

For: PHOTOMASK, PATTERN FORMATION METHOD USING PHOTOMASK AND MASK
DATA CREATION METHOD

PRELIMINARY AMENDMENT

Mail Stop Preliminary Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows: